



AF/1763

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<u>Stephanie Lindquist</u> Signature	10/01/02 Date

PATENT  
Docket No. 13DV-13228

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Robert W. Bruce et al.

Examiner: Rudy Zervigon

Serial No.: 09/624,810

Art Unit: 1763

Filed: July 24, 2000

For: ELECTRON BEAM PHYSICAL VAPOR DEPOSITION APPARATUS

**SUBSTITUTE DRAWINGS**

Assistant Commissioner for Patents  
Washington, D.C. 20231

**Attention: OFFICIAL DRAFTSPERSON**

In response to the Office Action dated July 31, 2002 (Paper No. 8), please  
substitute the enclosed two (2) sheets of drawings for sheet numbers 8 (Figure 10) and 9  
(Figures 11 and 12) of the drawings originally submitted with the above-identified United